



Application Serial No. 10/678,513
Response to June 26, 2006 Office Action

MI22-2391

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/678,513
Filing Date October 3, 2003
Inventor..... Werner Juengling
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2823
Examiner Brook Kebede
Attorney's Docket No. MI22-2391
Customer No. 021567
Title: Semiconductor Processing Methods Of Forming A Contact Opening To A Conductive Line and Methods of Forming Substrate Active Area Source/Drain Regions

RESPONSE TO JUNE 26, 2006 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
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Responsive to the Office Action dated June 26, 2006, Applicant amends and remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.

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03 FC:1202

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